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Serial Number: 10/525,919

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PALM INTRANET

Inventor Information for 10/525919

Inventor Name	City	State/Country
NAGATA, YOSHIHIKO	IBARAKI	JAPAN
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US 20060141209 A1	US- PGPUB	20060629	8	Pellicle for photolithography and pellicle frame	428/131	355/75; 430/5	Nagata; Yoshihiko
US 20050281954 A1	US- PGPUB	20051222		Method for producing a pellicle for lithography	427/356	427/372.2	Nagata, Yoshihiko
US 20050096541 A1	US- PGPUB	20050505		Panniculus measuring apparatus using ultrasound	600/437	600/447	Fukuda, Osamu
US 20050085728 A1	US- PGPUB	20050421		Apparatus and program for estimating viscoelasticity of soft tissue using ultrasound	600/449		Fukuda, Osamu
US 20050048380 A1	US- PGPUB	20050303		Pellicle for lithography	430/5	428/14	Nagata, Yoshihiko
US 20050011949 A1	US- PGPUB	20050120		Card reader	235/441		Fukuda, Osamu
US 20040091796 A1	US- PGPUB	20040513		Pellicle for lithography, and a method for producing it	430/5	428/14; 430/322	Nagata, Yoshihiko
US 20020142768 A1	US- PGPUB	20021003		Position display system using wireless mobile terminals	455/457		Murata, Kunio et a
US 7067222 B2	USPAT	20060627		Pellicle for lithography	430/5		Nagata; Yoshihiko
US 6988659 B2	USPAT	20060124		Card reader	235/441	235/479; 235/492; 439/159; 439/160; 439/630	Fukuda; Osamu
US D471413 S	USPAT	20030311		Stapler	D8/49	D19/72; D8/50	Fukuda; Osamu
US 6396579 B1	USPAT	20020528		Method, apparatus, and system for inspecting transparent objects	356/239.7	250/559.4; 250/559.41; 356/239.8	Hayamizu Mitsuru et al.
US 5693382 A	USPAT	19971202		Frame-supported pellicle for	428/14	359/350; 428/421;	Hamada; Yuichi et

				dustproof protection of photomask in photolithography		428/422	al.
US 5691088 A	USPAT	19971125		Pellicle for protection of photolithographic mask	430/5	428/343; 428/355R; 428/45	Kubota; Yoshihiro et al.
US 5616927 A	USPAT	19970401		Frame-supported pellicle for dustproof protection of photomask	250/492.2	355/53; 378/35; 428/14	Kubota; Yoshihiro et al.
US 5540577 A	USPAT	19960730		Injection molding machine capable of reducing the work required to an operator	425/150	264/40.5	Ishikawa; Atsushi et al.
US 5470621 A	USPAT	19951128		Frame-supported pellicle for dustproof protection of photomask	428/14	355/122	Kashida; Meguru et al.
US 5419972 A	USPAT	19950530		Frame-supported pellicle for dustproof protection of photomask	428/626	428/650; 428/651; 428/652; 428/654	Kawaguch Sakae et a
US 5378514 A	USPAT	19950103		Frame-supported pellicle for photolithography	428/14	156/322; 156/344; 428/421; 428/422	Hamada; Yuichi et al.
US 5368675 A	USPAT	19941129		Method for the preparation of a frame-supported pellicle for photolithography	156/544	156/584; 427/164; 427/335; 427/372.2; 427/385.5; 427/389.7; 427/409	Hamada; Yuichi et al.
US 5327808 A	USPAT	19940712		Method for the preparation of a frame-supported pellicle for photolithography	83/861	156/267; 83/16; 83/171; 83/914	Nagata; Yoshihiko et al.
US 5326649 A	USPAT	19940705		X-ray transmitting membrane for	428/698	378/35; 427/160;	Kashida; Meguru et

				mask in x-ray lithography and method for preparing the same		427/250; 427/255.394; 427/372.2; 428/157; 428/446; 428/45; 428/704; 430/5	al.
US 5308567 A	USPAT	19940503		Method for the preparation of a resin membrane	264/127	264/216	Kashida; Meguru et al.
US 5300348 A	USPAT	19940405		Frame-supported pellicle for photolithography, comprising a fluorocarbon containing organopolysiloxane based adhesive	428/194	428/14; 428/421; 428/447; 430/5	Kubota; Yoshihiro et al.
US 5286567 A	USPAT	19940215		Pellicle for photolithographic mask	428/422		Kubota; Yoshihiro et al.
US 5246802 A	USPAT	19930921		X-ray permeable membrane for X-ray lithographic mask	430/5	204/192.26; 378/35	Kashida; Meguru et al.
US 5234609 A	USPAT	19930810		X-ray permeable membrane for X-ray lithographic mask	252/1	264/81; 378/35; 427/160; 427/255.393; 430/5	Kashida; Meguru et al.
US 5209996 A	USPAT	19930511		Membrane consisting of silicon carbide and silicon nitride, method for the preparation thereof and mask for X-ray lithography utilizing the same	430/5	204/192.1; 204/192.26; 216/67; 216/79; 378/34; 378/35; 428/446; 428/698; 430/966; 501/92	Kashida; Meguru et al.
US 5199055 A	USPAT	19930330		X-ray lithographic mask blank with reinforcement	378/35	378/210	Noguchi; Hitoshi et al.
US 5196399 A	USPAT	19930323		Apparatus for producing oxide	65/443	204/192.24; 204/298.03;	Shiota; Takao et a

				superconductor cable		204/298.24; 204/298.35; 257/E39.018; 505/731; 505/740; 505/816; 505/821	
US 5139633 A	USPAT	19920818		Film-forming on substrate by sputtering	204/192.15	204/192.23	Kashida; Meguru et al.
US 5098515 A	USPAT	19920324		Method for the preparation of a silicon carbide-silicon nitride composite membrane for X-ray lithography	430/5	204/192.1; 216/12; 378/35	Kashida; Meguru et al.
US 5093311 A	USPAT	19920303		Oxide superconductor cable and method of producing the same	505/232	204/192.24; 204/298.24; 257/E39.018; 428/332; 428/334; 428/357; 428/426; 428/433; 428/688; 428/698; 428/930; 505/238; 505/701; 505/702; 505/703; 505/704	Shiota; Takao et a
US 5089085 A	USPAT	19920218		Silicon carbide membrane for X-ray lithography and method for the preparation thereof	216/2	204/192.1; 216/99; 378/35; 430/5	Kashida; Meguru et al.
US 5070733 A	USPAT	19911210		Photoacoustic imaging method	73/602	73/606; 73/643	Nagata; Yoshihiko et al.
US 5057484 A	USPAT	19911015		Single crystal oxide superconductor and method of producing the same	505/125	428/426; 428/457; 428/688; 428/689; 428/698;	Shiota; Takao et a

						428/699; 428/700; 428/901; 428/930; 505/183; 505/232; 505/235; 505/236; 505/237; 505/238; 505/434; 505/447; 505/470; 505/473; 505/475; 505/701; 505/702; 505/703; 505/704	
US 5029961 A	USPAT	19910709		Optical fiber coupler and process for manufacturing same	385/50	385/126; 385/15	Suzuki; Fumio et al.
US 4970197 A	USPAT	19901113		Oxide superconductor	505/230	29/599; 428/688; 428/698; 428/930; 505/236; 505/237; 505/701; 505/702; 505/704	Shiota; Takao et al.
US 4935045 A	USPAT	19900619		Method of manufacturing a preform for asymmetrical optical fiber	65/412	427/167; 65/422; 65/426; 65/428	Yamauchi Ryozo et al.
US 4896941 A	USPAT	19900130		Image-transmitting fiber	385/116	600/182	Hayashi; Shotaro et al.
US 4834786 A	USPAT	19890530		Method of manufacturing a preform for asymmetrical optical fiber	65/412	427/167	Yamauchi Ryozo et al.

US 4770493 A	USPAT	19880913		Heat and radiation resistant optical fiber	385/102	385/128; 385/141	Ara; Kuniaki et al.
US 4514496 A	USPAT	19850430	10	Process for producing alcohol by fermentation without cooking	435/162	426/13; 426/16; 426/29; 435/161	Yoshizum Hajime et al.
US 4388098 A	USPAT	19830614		Apparatus for producing multi-component glass fiber preform	65/157	422/129	Takahashi Shiro et al
US 4336049 A	USPAT	19820622		Method for producing multi-component glass fiber preform	65/390	65/413; 65/430	Takahashi Shiro et al